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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	Examiner: Unassigned
IZUMI TSUKAMOTO, ET AL.	)	Group Art Unit: 2812
Application No.: 09/640,724	)	
Filed: August 18, 2000	)	
For: SUBSTRATE ATTRACTING AND	)	January 10, 2001
HOLDING SYSTEM FOR USE IN	)	
EXPOSURE APPARATUS	)	

The Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

To comply with the duty of disclosure under 37 CFR 1.56 and in accordance with the practice under 37 CFR 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 Form. Copies of the listed documents are also enclosed.

(1) Japanese patent No. 2574818 is discussed on page 5 of the subject specification and relates to a vacuum suction anchor block.

(2) Japanese patent No. 2821678 is discussed on pages 6 through 8 of the subject specification and relates to a suction device for a substrate and an aligner.

Applicants request that the Examiner consider the cited information and return an initialed copy of the enclosed PTO-1449 Form indicating that such information has been considered.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,



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